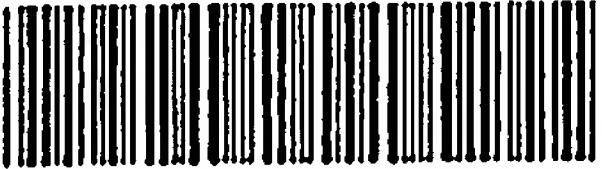


<b>Search Notes</b> 				Application/Control No.	Applicant(s)/Patent under Reexamination	
				10/604,641	PONZIO, MASSIMO	
				Examiner	Art Unit	
				José V. Chen	3637	
<b>SEARCHED</b>				<b>SEARCH NOTES (INCLUDING SEARCH STRATEGY)</b>		
Class	Subclass	Date	Examiner		DATE	EXMR
100	55.1	3/22/06	JVC	Feedback Sources	3/22/06	JVC
	55.3			Re. Prod. Pat		
	57.11					
198	803.11			PTA Cos	10/12/06	JVC
	803.01					
269	56			VOIP Cos	4/16/07	JVC
	55					
	292					
<b>INTERFERENCE SEARCHED</b>						
Class	Subclass	Date	Examiner			